

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Zia Hossain ET AL
 FILED: Concurrently Herewith
 FOR: LATERAL FET STRUCTURE WITH IMPROVED
 BLOCKING VOLTAGE AND ON RESISTANCE
 Date: 12/2/2003

DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56

Honorable Assistant Commissioner for Patents
 Arlington, VA 22313-1450

SIR:

It is respectfully requested that the prior art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed prior art is enclosed herewith.

No representation is made or intended that the listed prior art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted,
 Zia Hossain et al



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27255

Form PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use Several Sheets if Necessary)	ATTY. DOCKET NO.	SERIAL NO.
	ONS00478	
	APPLICANT Zia Hossain et al	
	FILING DATE	GROUP
	CONCURRENTLY	

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial	Document Number									Date	Name	Class	Sub-Class	Filing date (If appropriate)
AA	5	6	3	3	5	2	1			5/27/1997	Koishikawa	H01L	29/76	
AB	5	2	5	8	6	3	6			11/2/1993	Rumennik et al	H01L	29/80	
AC	5	9	1	0	6	7	0			6/8/1999	Ludikhuize	H01L	29/10	
AD	6	4	4	8	6	2	5			9/10/2002	Hossain et al	H01L	23/58	
AE	6	5	5	5	8	8	3			4/29/2003	Disney et al	H01L	29/76	
AF														
AG														
AH														
AI														
AJ														
AK														
AL														
AM														

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document #	Date	Country	Class/subclass	Translation Yes - No
AN					
AO					
AP					
AQ					
AR					

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AS	
AT	
AU	
AV	
AW	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.